

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of	)	
Shin HASHIMOTO et al.	)	Group Art Unit: 1765
Application No. 09/856,823	)	
Filed: May 25, 2001	)	Examiner: Matthew J. SONG
For: METHOD FOR FABRICATING	)	
SEMICONDUCTOR DEVICE	)	

**CERTIFICATE OF MAILING OR TRANSMISSION**

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage for first class mail in an envelope addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, Virginia 22313-1450, or being facsimile transmitted to the USPTO at (703) 872-9311, on July \_\_\_\_, 2003.

\_\_\_\_\_  
April Campbell

**AMENDMENT**

Mail Stop RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In response to the final Office Action mailed February 21, 2003, please amend the above identified application as follows.